## 504791494 02/23/2018

## PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE

#### **CONVEYING PARTY DATA**

Name	Execution Date
UNIVERSITY OF CALIFORNIA, BERKELEY	04/22/1997

#### **RECEIVING PARTY DATA**

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### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	08796301

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DATE SIGNED: 02/23/2018

**Total Attachments: 2** source=4312#page1.tif source=4312#page2.tif

PATENT 504791494 REEL: 045431 FRAME: 0992

### NSF

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:	Apparatus and Method for Optical Scanning with an Oscillatory Microelectromechanical System			
;	08/796,301			
:	February 7, 1997			
;	Not yet determined			
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